Nanocomposites and nanomaterials

Metal-semiconductor nanocomposites based on porous InP

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Porous materials and porous semiconductors in particular show much promise for different applications such as photonics, optoelectronics, sensorics etc. due to possibility simply tuning their properties and large surface-to-volume ratio. In contrast to porous silicon and the composites based on por-Si which are well investigated, the porous III-V semiconductors are poorly studied [1,2]. In this work we propose a facile and cheap method for the fabrication of a new class of nanocomposite materials, viz., ordered porous III-V semiconductor layers with metal nanoparticles incorporated into the pores.

In a first step porous InP with different thickness have been prepared from ntype (100) single crystals by anodization in 5% HCl electrolyte in the galvanostatic regime. Metal was incorporated in porous layer in electrochemical cell by two different techniques: from the solution of the Au salt and using spherical Au nanoparticles with SiO₂ shell. SEM investigations show that we can fabricate both ordered and disordered porous layers of essentially different morphology, with layer parameters varied in a very wide range: porosity was from 10% to 70%, diameter of pores was in the range 50 - 200 nm and porous layer thickness was 5 -90 μ m. The InP porous layers appear as a system of cylindrical cavities or embedded tetrahedrons demonstrating a horizontal-plane correlation between neigbouring pores. Surface of the sample is "decorated" with metal particles, whereas the cleavage image exhibits that the metal nanoparticles also fill pores.

1. Dmitruk N., Barlas T., Serdyuk V. A³B⁵ Porous Semiconductors:

Electrochemical Technology, Structure and Optical Properties // Physics and Chemistry of Solid State.-2010.-**11**.-P. 13-33.

2. *Barlas T.R., Dmitruk N.L., Serdyuk V.A.* Characterization of porous polar semiconductors by their optical spectra in the region of phonon and plasmon-phonon excitations // Opt. Spectrosc.-2012.-**112**.-P. 233-242.